Vertically Reinforced 1-3 Piezoelectric Composites for Active Damping of Functionally Graded Plates

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Introduction

MONOLITHIC piezoelectric materials (PZTs) have been widely used as distributed sensors and actuators for developing smart structures with self-monitoring and self-controlling capabilities [1–10]. However, their major drawback is low control authority as the magnitude of their electromechanical coefficients is very small. The situation can be improved by using an active constrained layer damping (ACLD) treatment [11,12] which consists of a layer of a viscoelastic material constrained between a host structure and an active constraining PZT layer. When the constraining layer is activated with a voltage applied to the PZT layer, the shearing deformations of the viscoelastic layer are enhanced to improve the damping characteristics of the overall structures. Since its inception, the ACLD treatment has been extensively used for efficient and reliable control of flexible structures [13–17].

Piezoelectric composites, also called piezocomposites, have emerged as a new class of smart materials and have found wide applications as distributed actuators and sensors. A piezocomposite, composed of PZT reinforcements embedded in a conventional epoxy matrix, provides a wide range of effective material properties not offered by existing PZTs, is anisotropic, and has good conformability and strength. We note that laminae of vertically reinforced 1-3 piezocomposites are commercially available [18] and are being effectively used as underwater high-frequency transducers and in medical imaging applications [19,20]. A 1-3 piezocomposite lamina has PZT fibers vertically reinforced in the epoxy matrix across the thickness of the lamina, the fibers are poled along their length, and the top and bottom surfaces of the lamina are electroded. The effective PZT coefficient (ε33) of the 1-3 piezocomposite, which equals the normal stress (σ3) along the fiber direction due to a unit electric field applied across the thickness of the piezocomposite lamina, is much larger than the effective coefficients ε31 and ε32 which signify the induced normal stresses (σ3, σ0) in directions transverse to the fiber. However, very little attention has been paid to using these 1-3 piezocomposites for active vibration control [21].

Until recently, the host structure in a smart system has been considered to be made of a homogeneous and either isotropic or orthotropic material. Recently, functionally graded materials (FGMs) which exhibit smooth variation of material properties in one or more directions have been investigated for developing high-performance smart FG structures [22–27]. We also note that Batra and Geng [12] considered a FG viscoelastic layer but a homogeneous PZT constraining layer and performed the three-dimensional transient analysis of the problem with the finite element method (FEM). However, it appears that the performance of a vertically reinforced 1-3 piezocomposite has not yet been investigated for active control of FG structures.

Here, we use a first-order shear deformation plate theory (FSDT) and the FEM to analyze ACLD of FG plates with the objective of investigating the performance of the vertically reinforced 1-3 piezocomposite as the material of the constraining layer.

Problem Statement and Basic Equations

A schematic sketch of the problem studied is shown in Fig. 1. The thicknesses of the substrate FG plate, piezocomposite layer, and the viscoelastic layer are denoted by h, h0, and h1, respectively. The mid-surface of the substrate plate is taken as the reference plane with the origin of the rectangular Cartesian coordinate system (xyz) located in it such that lines x = 0, a and y = 0, b represent boundaries of the substrate plate.

The overall smart structure is assumed to be thin; thus the FSDT is used to model its deformations. Accordingly, displacements u, v, w of a point along the x, y, and z directions, respectively, are expressed as

\[
\begin{align*}
\mathbf{u}(x, y, z) &= u_0(x, y, t) + \lambda_1(z)\theta_x(x, y, t) + \lambda_2(z)\phi_x(x, y, t) \\
&\quad + \lambda_3(z)\phi_y(x, y, t) \\
\mathbf{v}(x, y, z) &= v_0(x, y, t) + \lambda_1(z)\theta_y(x, y, t) + \lambda_2(z)\phi_y(x, y, t) \\
&\quad + \lambda_3(z)\phi_y(x, y, t) \\
\mathbf{w}(x, y, z) &= w_0(x, y, t) + \lambda_1(z)\theta_z(x, y, t) + \lambda_2(z)\phi_z(x, y, t) \\
&\quad + \lambda_3(z)\phi_z(x, y, t)
\end{align*}
\]

where \(\lambda_1(z) = z - (x - b_2), \lambda_2(z) = (z - h_1) - (x - b_1), \lambda_3(z) = (z - h_1) - h_1 = h_1/2, h_2 = h_1/2 + h_0\). Variables \(u_0, v_0, w_0\) and \(\theta_x, \phi_x, \phi_y, \phi_z\) represent the generalized translational displacement of a point (x, y) on the reference plane (z = 0) along the x, y, and z directions, respectively; \(\theta_x, \phi_x, \phi_y, \phi_z\) denote the generalized rotations of normals to the midplane of the substrate plate, the viscoelastic layer and the piezocomposite layer, respectively, in the \(xz\) plane while \(\theta_y, \phi_y, \phi_z\) represent their generalized rotations in the \(yz\) plane. Variables \(\theta_x, \phi_x, \phi_y, \phi_z\) and \(\gamma_x\) are generalized displacements representing gradients with respect to z of the transverse displacement in the substrate plate, the viscoelastic layer, and the piezocomposite layer, respectively, \(t\) is the time variable and a function within the bracket (·) represents an appropriate singularity function for satisfying the continuity of displacements at an interface between any two...
Fig. 1 Schematic sketch of a functionally graded plate integrated with patches of a viscoelastic layer and a constraining layer composed of 1-3 piezoelectric composite.

Using strain-displacement relations and Eq. (8), the strain vectors, given by Eq. (5), at a point in a finite element can be expressed in terms of the generalized nodal displacements \( \{ u_n \} \) and \( \{ \theta_n \} \):

\[
\{ \varepsilon_n \} = \left[ \begin{array}{c}
\varepsilon_x \\
\varepsilon_y \\
\varepsilon_z \\
\gamma_{xy} \\
\gamma_{xz} \\
\gamma_{yz}
\end{array} \right]
\]

where \( \varepsilon_x, \varepsilon_y, \varepsilon_z, \gamma_{xy}, \gamma_{xz}, \gamma_{yz} \) are normal strains along the \( x, y, \) and \( z \) directions, respectively; \( \varepsilon_{xy} \) is the in-plane shear strain; and \( \varepsilon_{xz}, \varepsilon_{yz} \) are transverse shear strains while \( \sigma_x, \sigma_y, \sigma_z, \sigma_{xy}, \sigma_{xz}, \sigma_{yz} \) and \( \gamma_{xy}, \gamma_{xz}, \gamma_{yz} \) are corresponding stresses. Thus constitutive relations for the FGM can be expressed as:

\[
\sigma_n = [C_n] \varepsilon_n \quad \text{and} \quad \sigma_z = [C_z] \varepsilon_z
\]

and the vertically reinforced 1-3 piezocomposite are given by [19]

\[
\varepsilon_n = [C_n] \varepsilon_n - [K_n] E_n
\]

where \( [C_n] \) and \( [C_z] \) are the elastic coefficient matrices, \( D_z \) equals the electric displacement in the \( z \) direction, \( \varepsilon_{33} \) is the dielectric constant, and \( \varepsilon_{31} = \varepsilon_{32} = \varepsilon_{33} = 0 \). The viscoelastic layer is assumed to be made of an homogenous and isotropic material. Employing the complex modulus approach, its constitutive relations can also be expressed by Eq. (6) [11,13,14].

**Approximate Solution by the Finite Element Method**

For brevity, the generalized degrees of freedom of a point in the overall structure are grouped into the following two vectors:

\[
\{ d_1 \} = [u_0 \quad v_0 \quad w_0]^T \quad \text{and} \quad \{ d_2 \} = [\theta_x \quad \theta_y \quad \theta_z \quad \phi_x \quad \phi_y \quad \phi_z \quad \gamma_x \quad \gamma_y \quad \gamma_z]^T
\]

\[
\{ d_3 \} = [u \quad v \quad w]^T \quad \text{and} \quad \{ d_4 \} = [\theta_x \quad \theta_y \quad \theta_z \quad \phi_x \quad \phi_y \quad \phi_z \quad \gamma_x \quad \gamma_y \quad \gamma_z]^T
\]

where \( \theta_x, \theta_y, \theta_z \) are rotational degrees of freedom about the \( x, y, \) and \( z \) axes, respectively, and \( \phi_x, \phi_y, \phi_z \) are rotations about the \( x, y, \) and \( z \) axes, respectively; \( \gamma_{xy}, \gamma_{xz}, \gamma_{yz} \) are shear strains. Thus, the 1-3 piezocomposite layer is along the \( z \) direction according to

\[
\varepsilon_z = \frac{1}{E_z} \left( \frac{1}{2} + (-1)^k \frac{z}{h} \right) + \rho_m
\]

where \( E_z \) is the in-plane shear strain; and

\[
\lambda_\varphi(z) = \frac{1}{E_{\varphi}} \left( \frac{1}{2} + (-1)^k \frac{z}{h} \right) + \rho_m
\]

is the dielectric constant.

\[
\lambda_\varphi(z) = \frac{1}{E_{\varphi}} \left( \frac{1}{2} + (-1)^k \frac{z}{h} \right) + \rho_m
\]

and

\[
\lambda_{\varphi}(z) = \frac{1}{E_{\varphi}} \left( \frac{1}{2} + (-1)^k \frac{z}{h} \right) + \rho_m
\]

is a positive integer. Note

\[
\lambda_\varphi(z) = \frac{1}{E_{\varphi}} \left( \frac{1}{2} + (-1)^k \frac{z}{h} \right) + \rho_m
\]

and

\[
\lambda_{\varphi}(z) = \frac{1}{E_{\varphi}} \left( \frac{1}{2} + (-1)^k \frac{z}{h} \right) + \rho_m
\]

are normal strains along the \( x, y, \) and \( z \) directions, respectively, \( E_{\varphi} \) and \( \rho_m \) are Young’s modulus and Poisson’s ratio of the ceramic phase, respectively, \( E_m \) and \( \rho_m \) are the same for the metallic phase, \( n \) is the power law exponent, and \( k \) is a positive integer. Note that the top surface of the FG plate will be either the stiffest (metallic) or the stiffest (ceramic) according as \( k \) equals 1 or 2, respectively. Poisson’s ratio \( v \) of the FGM is assumed to be a constant [19] because it does not vary much for several combinations of ceramics and metals. It is also assumed that the electric field \( E_z \) applied to the piezocomposite layer is along the \( z \) direction. To implement the selective integration rule for deriving the stiffness matrices of an element corresponding to bending and transverse shear deformations separately, stresses and strains at a point are grouped as:

\[
\{ \sigma_n \} = \begin{bmatrix} \sigma_x & \sigma_y & \sigma_z \\ \sigma_{xy} & \sigma_{yz} & \sigma_{xz} \end{bmatrix} \quad \text{and} \quad \{ \sigma_z \} = \begin{bmatrix} \sigma_{x} & \sigma_{y} & \sigma_{z} \\ \sigma_{xy} & \sigma_{yz} & \sigma_{xz} \end{bmatrix}
\]

where \( \sigma_x, \sigma_y, \sigma_z \) are normal stresses along the \( x, y, \) and \( z \) directions, respectively; \( \sigma_{xy}, \sigma_{yz}, \sigma_{xz} \) are shear stresses; \( \varepsilon_{x}, \varepsilon_{y}, \varepsilon_{z} \) are normal strains along the \( x, y, \) and \( z \) directions, respectively; \( \varepsilon_{xy} \) is the in-plane shear strain; and \( \varepsilon_{xz}, \varepsilon_{yz} \) are transverse shear strains while \( \sigma_{x}, \sigma_{y}, \sigma_{z}, \sigma_{xy}, \sigma_{xz}, \sigma_{yz} \) and \( \varepsilon_{xy}, \varepsilon_{xz}, \varepsilon_{yz} \) are corresponding stresses. Thus constitutive relations for the FGM can be expressed as:

\[
\{ \sigma_n \} = \left[ \begin{array}{c} C_n \end{array} \right] \{ \varepsilon_n \} \quad \text{and} \quad \{ \sigma_z \} = \left[ \begin{array}{c} C_z \end{array} \right] \{ \varepsilon_z \}
\]

and

\[
\{ \sigma_n \} = \left[ \begin{array}{c} C_n \end{array} \right] \{ \varepsilon_n \} \quad \text{and} \quad \{ \sigma_z \} = \left[ \begin{array}{c} C_z \end{array} \right] \{ \varepsilon_z \}
\]

and

\[
\{ \sigma_n \} = \left[ \begin{array}{c} C_n \end{array} \right] \{ \varepsilon_n \} \quad \text{and} \quad \{ \sigma_z \} = \left[ \begin{array}{c} C_z \end{array} \right] \{ \varepsilon_z \}
\]
For an element of length $a$, and width $b$, the element mass matrix $[M^e]$, stiffness matrices $[K_{11}^e], [K_{22}^e], [K_{33}^e]$, the electroelastic coupling vectors $\{F_{ep}\}$ and the load vector $\{F\}$ are given by

$$
[K_{11}^e] = \int_{a}^{b} \int_{0}^{a} \int_{0}^{b} \left( [B_{bh}]^T [C_b] [B_{bh}] + [B_{bh}]^T [C_b] [B_{bh}] \right) \, dx \, dy \, dz
$$

$$
[K_{22}^e] = \int_{a}^{b} \int_{0}^{a} \int_{0}^{b} \left( [B_{bh}]^T [C_b] [Z_b] [B_{bh}] + [B_{bh}]^T [C_b] [Z_b] [B_{bh}] \right) \, dx \, dy \, dz
$$

$$
[K_{33}^e] = \int_{a}^{b} \int_{0}^{a} \int_{0}^{b} \left( [B_{bh}]^T [C_b] [Z_b] [B_{bh}] \right) \, dx \, dy \, dz
$$

$$
[M^e] = \int_{0}^{a} \int_{0}^{b} \left( \hat{m} [N_i]^T [N_j] \right) \, dx \, dy
$$

where $\{F\}$ is the externally applied surface traction. Here we have neglected the rotary inertia because of the small thickness of the overall structure. For an element not integrated with the ACLD treatment, the electroelastic coupling matrices become null matrices and the element stiffness matrices are real. Equations (12) and (13) are assembled to obtain the following open loop global equations of motion:

$$
[M] \ddot{\mathbf{X}} + [K_{11}] \mathbf{X} + [K_{22}] \mathbf{X} = \sum_{j=1}^{q} \left\{ F_{ep} \right\} \mathbf{V}^j + \{ F \}
$$

and

$$
[K_{11}] \mathbf{X} + [K_{22}] \mathbf{X} = \sum_{j=1}^{q} \left\{ F_{ep} \right\} \mathbf{V}^j
$$

where $[M]$ is the global mass matrix, $[K_{11}], [K_{22}], [K_{33}]$ are global stiffness matrices, $\{F_{ep}\}$ are global electroelastic coupling vectors, $\{X\}$ and $\{X\}$ are global nodal generalized displacement vectors, $\{F\}$ is the global nodal force vector, $q$ is the number of patches, and $\mathbf{V}^j$ is the voltage difference applied to the $j$th patch.

### Active Damping

The constraining layer of each patch is activated with a voltage proportional to the transverse velocity of a point. That is

$$
\mathbf{V}^j = -k_{d} \ddot{\mathbf{w}} = -k_{d} \left[ \ddot{U}_{j}(\mathbf{X}) - k_{d}(h/2) \ddot{U}_{j}(\mathbf{X}) \right]
$$

where $k_{d}$ is the control gain for the $j$th patch, and unit vectors $\{U\}$ and $\{U\}$ locate the velocity sensors. Substituting from Eq. (17) into Eqs. (15) and (16), equations of motion governing the closed loop dynamics of the overall FG plate/ACLD system become

$$
[M] \ddot{\mathbf{X}} + \sum_{j=1}^{m} \left( k_{d} \right) \left[ \ddot{U}_{j}(\mathbf{X}) + \sum_{j=1}^{m} \left( k_{d}(h/2) \right) \ddot{U}_{j}(\mathbf{X}) \right] = \{ F \}
$$

and

$$
\sum_{j=1}^{m} \left( k_{d} \right) \left[ \ddot{U}_{j}(\mathbf{X}) + \sum_{j=1}^{m} \left( k_{d}(h/2) \right) \ddot{U}_{j}(\mathbf{X}) \right] + \{ K_{11} \} \mathbf{X} + \{ K_{22} \} \mathbf{X} = \{ 0 \}
$$

### Results and Discussion

Using eight nodded isoparametric elements, we compute results for square FG Al/Al2O3 substrate plates integrated with two ACLD patches, shown in Fig. 1, and the constraining layer composed of the 1-3 PZT-5H/spur composite with 60% volume fraction of PZT-5H fibers. Values assigned to effective material parameters of the piezocomposite are [19] $C_{11} = 9.29$ GPa, $C_{12} = 6.18$ GPa, $C_{13} = C_{33} = 6.05$ GPa, $C_{44} = C_{55} = 35.44$ GPa, $C_{66} = 1.58$ GPa, $C_{55} = C_{66}$, $C_{44} = 1.54$ GPa, $e_{31} = e_{13} = -0.1902$ C/m$^2$, $e_{15} = 18.4107$ C/m$^2$, respectively.

### Table 1 Comparison of natural bending frequencies ($\omega$) of square FG plates ($a/h = 10$)

<table>
<thead>
<tr>
<th>FG plates</th>
<th>Source</th>
<th>Mode (1,1)</th>
<th>Mode (1,2)</th>
<th>Mode (2,2)</th>
</tr>
</thead>
<tbody>
<tr>
<td>n = 0.5</td>
<td>Present FEB</td>
<td>0.02517</td>
<td>0.06039</td>
<td>0.09319</td>
</tr>
<tr>
<td></td>
<td>Ref. [28]</td>
<td>0.02521</td>
<td>0.06048</td>
<td>0.09323</td>
</tr>
<tr>
<td>n = 1.5</td>
<td>Present FEB</td>
<td>0.02158</td>
<td>0.05178</td>
<td>0.07982</td>
</tr>
<tr>
<td></td>
<td>Ref. [28]</td>
<td>0.02165</td>
<td>0.05188</td>
<td>0.07991</td>
</tr>
</tbody>
</table>

* $\omega = \omega_0 \sqrt{\rho_0 (1 + \nu)/E_0}$, $\omega$ is the circular natural frequency, $\rho_0 = 1$ kg/m$^3$, and $E_0 = 1$ GPa.
Fig. 2 Frequency response functions for the transverse displacement $w$ of the point $(a/2, a/4, h/2)$ of a simply supported FG plate ($k = 1$, $n = 2$).

Fig. 3 Variation of the control voltage with the frequency of excitation for the ACLD of the FG plate ($k = 1$, $n = 2$).

Fig. 4 Frequency response functions for the transverse displacement $w$ of the point $(a/2, a/4, h/2)$ of the FG plate demonstrating the contribution of the transverse actuation of the constraining layer ($k_d = 1200$, $k = 1$, $n = 2$).

n = 2. The variation of the control voltage applied to each patch with the frequency of excitation is shown in Fig. 3. Results plotted in Fig. 2 clearly reveal that if the constraining layer of the ACLD treatment is made of vertically reinforced 1-3 piezocomposite, the activated patches significantly attenuate the amplitude of vibrations, and enhance damping characteristics of the system over that of the passively damped system. Plots of Fig. 3 indicate that the maximum control voltage required to achieve this damping is quite low. To delineate contribution of the vertical actuation in improving the damping characteristics of the FG plate, active control responses of the FG plate for a gain of 1200 are plotted in Fig. 4 with and without considering $e_{31}$ and $e_{11}$. Note that for $e_{31} = 0$ and $e_{11} \neq 0$, the vertical actuation by the ACLD treatment dampens motion of the FG plate. However, when $e_{31} = 0$ and $e_{11} \neq 0$, the in-plane actuation of the ACLD annuls motions of the FG plate. It is evident from results depicted in Fig. 4 that the contribution of the vertical actuation of the ACLD treatment is significantly larger than that of the in-plane actuation for controlling modes displayed in Fig. 2. This is due to the much higher value of the effective piezoelectric coefficient $e_{31}$ of the 1-3 piezocomposite constraining layer than that of $e_{31}$. Thus one must consider the transverse normal strain of the constraining layer even if it is a monolithic PZT with $|e_{31}| > |e_{11}|$. It suggests that the shear and normal deformable plate theory of Batra and Vidoli [29] may give better results than the FSDT.

Figures 5 and 6 illustrate that for the same locations ACLD patches bonded to the softest surface (metal rich, $k = 1$) of the FG plate cause more attenuation of vibrations (Fig. 5) with less control voltage (Fig. 6) than when they are attached to the stiffest surface (ceramic rich, $k = 2$) of the plate. Note that in the FG plate material properties vary through the thickness thereby coupling bending and stretching deformations. This coupling is reduced if patches are attached to the softest surface of the substrate FG plate resulting in an improved performance of the ACLD treatment when patches are bonded to the softest surface of the FG plate.

Conclusions

The performance of vertically reinforced 1-3 piezoelectric composite distributed actuator in the ACLD system bonded to a functionally graded FG plate has been investigated. Deformations of each layer in the system are modeled by the first-order shear deformable theory and the resulting 2-dimensional problem is analyzed by the finite element method. The present work considers transverse normal strains induced in each layer thereby using both vertical and in-plane actuations caused by the constraining layer. The frequency response of the FG plate of the system indicates that the active constraining layer of the ACLD treatment significantly enhances damping characteristics of the plate over that caused by passive damping. It is also found that transverse deformations of the constraining and hence of the constrained layer induce significantly larger damping of the FG plate than that caused by their in-plane deformations. Furthermore, the patches’ performance is maximum...
when they are bonded to the softest (metal rich) surface of the host FG plate.

References


[18] Piezocomposites, Materials Systems, Inc., 543 Great Road, Littleton, MA 01460.


K. Shivakumar
Associate Editor